

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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|-------------|---|-------------|----------------------|
| Applicant:  | Yeo, <i>et al.</i>  | Docket No.: | TSM03-0760           |
| Serial No.: | 10/803,712  | Art Unit:   | 1756                 |
| Filed:      | March 18, 2004  | Examiner:   | Raymond, Brittany L. |
| For:        | Immersion Fluid for Immersion Lithography, and Method of Performing Immersion Lithography |             |                      |

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

Dear Sir:

The following remarks are presented in response to the Examiner's Office Action mailed September 21, 2007.